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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Eui-Hyeok Yang et al. Art Unit : 2812
Att. No. : 10/005,765 Examiner :
Filed : November 2, 2001
Title : WAFER-LEVEL TRANSFER OF MEMBRANES IN SEMICONDUCTOR
PROCESSING

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information Disclosure Statement and documents listed on form PTO-1449.

This filing is being made before the receipt of a first Office action on the merits. No fee is required.

The documents are in the English language; hence no concise explanation is necessary per Rule 98(a)(3).

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

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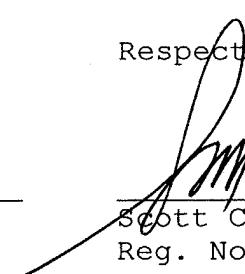
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Attorney's Docket No.: 06618-720001 / CIT-3325

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Respectfully submitted,

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Sheet 1 of 1

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 06618-720001	Application No. 10/005,765
Information Disclosure Statement by Applicant <small>(Use several sheets if necessary)</small>			
<small>INN 03 2002</small> <small>(37 CFR §1.98(b))</small>		Applicant Eui-Hyeok Yang and Dean V. Wiberg	
		Filing Date November 2, 2001	Group Art Unit 2812

U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes No
	AL						
	AM						
	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)							
Examiner Initial	Desig. ID	✓ Document					
	AQ	TE Bell and KD Wise, "A dissolved wafer process using a porous silicon..." Proc MEMS 98, Heidleberg Germany, 25-29, Jan 1998, pp. 251-256.					
	AR	CG Keller and RT Howe, "Hexile tweezers for teleoperated micro-assembly", Proc MEMS 97, Nagoya, Japan, 1997 pp. 72-77.					
	AS						
	AT						

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	